

Attorney Docket No.: AUB-06300

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yonhua Tzeng

Serial No.: 10/772,740

Filed: February 5, 2004

For: METHOD OF PLASMA

ENHANCED CHEMICAL VAPOR DEPOSITION OF DIAMOND USING METHANOL-BASED

SOLUTIONS

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Art Unit:2817

Examiner: Stouffer, Kelly M.

REQUEST FOR A ONE MONTH EXTENSION OF TIME

162 North Wolfe Road Sunnyvale, CA 94086 (408)530-9700

Customer Number 28960

Applicant hereby petition for a one month extension of time to answer the outstanding Office Action mailed May 12, 2008, regarding the above-identified patent application. Please find a check enclosed in the amount of \$465.00 which includes, the fee of \$405.00 for the request for continued examination plus \$60.00 to cover the extension of time within the first month.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: September 4, 2008

Jonathan O. Owens Reg. No.: 37,902

Attorneys for Applicant

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